

EAST Search History

EAST Search History (Prior Art)

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	133	substrate same magnetic same holder same actuat \$4	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:41
L2	5	substrate same magnetic same holder same actuat \$4 same wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:42
L3	275	substrate same magnetic same holder same wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:44
L4	106	substrate same magnetic same holder same wafer and sputtering	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:47
L5	18	substrate same magnetic same holder same wafer and sputtering not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:48
L6	289	substrate holder same wafer and sputtering not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:49
L7	8	substrate holder same magnetic same wafer and sputtering not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:49
L8	24	magnetic chuck same substrate and vacuum not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 08:51
L9	2	magnetic chuck same sputtering not plasma	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:07

L10	20	"118".clas. and magnetic chuck	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:07
L12	6	"3977806"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:09
L14	3545	sputtering same cvd same ion same etching	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:56
L15	1237	sputtering same cvd same ion same etching and @py<"2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:57
L16	107	"118".clas. and sputtering same cvd same ion same etching and @py<"2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 09:57
L17	3187	118/728.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:34
L18	261	118/728.ccls. and @py<"2003" and magnetic	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:34
L19	1260	118/52.ccls. and @py<"2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:34
L20	1560	269/21.ccls. and @py<"2003"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:34
L21	21	269/21.ccls. and @py<"2003" and clip and spring	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/06 10:35

S1	556	(matsumoto near2 takafumi).in. or (mikami near2 shun).in. or (hanzawa near2 kouichi).in. or (moriya near2 mineharu).in. or (odagi near2 nideyuki).in. or (shimada near2 tetsuya).in. or (kubo near2 masashi).in. or (ikeda near2 susumu).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:28
S3	442	((matsumoto near2 takafumi).in. or (mikami near2 shun).in. or (hanzawa near2 kouichi).in. or (moriya near2 mineharu).in. or (odagi near2 nideyuki).in. or (shimada near2 tetsuya).in. or (kubo near2 masashi).in. or (ikeda near2 susumu).in.) and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:29
S4	4	"6231732".pn. or "5421979".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:32
S5	8583	substrate same jig and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:39
S6	156	rotary same substrate same jig and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:39
S7	26	rotary same releasable same jig and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:43

S8	18	releasable same substrate same jig and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:44
S9	0	wafer an dreleasable same substrate same jig and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:45
S10	11	wafer and releasable same substrate same jig and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:45
S11	14	wafer and release same substrate same jig and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:45
S12	13	wafer and release same substrate same clip and @py<"2006"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 14:50
S13	2	"5421979".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/03 15:04
S20	1127	motor same actuate \$4 same electric signal	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 10:51
S21	746	motor same actuate \$4 same electric signal same control	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 10:51
S22	41	motor near10 actuate\$4 near10 electric signal same control	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 10:52
S26	6	releasable same substrate holder and wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 11:06
S28	55	electric signal near7 actuate near7 motor	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 11:12
S34	134	(fukushima near2 chikayasu).in. or (yamamura near2 kazuichi).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 12:45

S35	243	substrate holder same jig	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 12:54
S36	103	substrate holder same jig	US-PGPUB; USPAT	ADJ	ON	2010/05/05 12:54
S37	103	substrate holder same jig and jig	US-PGPUB; USPAT	ADJ	ON	2010/05/05 12:59
S38	127	(asakawa near2 teruo).in.	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:07
S41	61	"269".clas. and jig and @py<"2006" and wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:23
S42	259	"269".clas. and @py<"2006" and spring same release same push	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:28
S43	356	"269".clas. and @py<"2006" and spring same release same press	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:37
S44	26	"269".clas. and @py<"2006" and spring same release same wafer	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 13:49
S49	38	"269".clas. and @py<"2006" and spring same plunger same vacuum	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 14:22
S50	87	"269".clas. and @py<"2006" and spring same plunger and vacuum	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT	ADJ	ON	2010/05/05 14:22

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